orm PTO-1595 09 - 06	-2001 U.S. DEPARTMENT OF COMMERCI
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To the Honorable Commissioner of 1 10183	.ed original documents or copy thereof
Name of conveying party(ies):	2. Name and address of receiving party(ies)
Kevin M. Devereaux	Name: Micron Technology, Inc.
08/28/01	Internal Address:
Additional name(s) of conveying party(ies)	Street Address: 8000 S. Federal Way
attached?	- 0000 S. Federal Way
3. Nature of Conveyance:	60
x Assignment Merger	
Security Agreement Change of Name	City: Boise
Other	State: ID Zip: 83707-0006
Execution Date: August 24, 2001	Additional name(s) & Yes x No address(es) attached:
If this document is being filed together with a new application, the A. Patent Application No.(s): NYA	execution date of the new application is: August 24, 2001 B. Patent No.(s):
Additional numbers atta Name and address of party to whom correspondence	oched? Yes X No 6. Total number of applications and
concerning document should be mailed:	patents involved: 1
Name: Thomas J. D'Amico DICKSTEIN SHAPIRO MORIN & OSHINSKY L	LP 7. Total fee (37 CFR 3.41) \$ 40.00
Internal Address: Atty. Dkt.: M4065.0468/P468	x Enclosed
Street Address: 2101 L Street NW	Authorized to be charged to deposit account
	8. Deposit account number:
	04-1073
City: State: Zip: Washington DC 20037-1526	(Attach duplicate copy of this page if paying by deposit account
	E THIS SPACE
Statement and signature.	
To the best of my knowledge and belief, the foregoing is a true copy of the original document.	information is true and correct and any attached copy
Thomas I D'Amies	August 28, 2001
Thomas J. D'Amico	Signature
Name of Person Signing Total number of pages including cover sheet, at	Signature Date tachments, and documents: 3

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Docket No.: M4065.0477/P477 Micron No.: 01-0374

ASSIGNMENT AND AGREEMENT

For value received, I, Kevin M. Devereaux, hereby sell, assign and transfer to Micron Technology, Inc., a corporation of the State of Delaware, having an office at 8000 S. Federal Way, Boise, Idaho 83706-9632, U.S.A., and its successors, assigns and legal representatives, the entire right, title and interest, for the United States of America, in and to certain inventions related to an invention entitled METHOD AND APPARATUS FOR WAFER LEVEL TESTING OF SEMICONDUCTOR USING SACRIFICIAL ON DIE POWER AND GROUND METALIZATION, described in an application for Letters Patent of the United States, executed by me of even date herewith, and all the rights and privileges in said application and under any and all Letters Patent that may be granted in the United States for said inventions; and I also concurrently hereby sell, assign and transfer to Micron Technology, Inc. the entire right, title and interest in and to said inventions for all countries foreign to the United States, including all rights of priority arising from the application aforesaid, and all the rights and privileges under any and all forms of protection, including Letters Patent, that may be granted in said countries foreign to the United States for said inventions.

I authorize Micron Technology, Inc. to make application for such protection in its own name and maintain such protection in any and all countries foreign to the United States, and to invoke and claim for any application for patent or other form of protection for said inventions, without further authorization from me, any and all benefits, including the right of priority provided by any and all treaties, conventions, or agreements.

I hereby consent that a copy of this assignment shall be deemed a full legal and formal equivalent of any document which may be required in any country in proof of the right of Micron Technology, Inc. to apply for patent or other form of protection for said inventions and to claim the aforesaid benefit of the right of priority.

I request that any and all patents for said inventions be issued to Micron Technology, Inc. in the United States and in all countries foreign to the United States, or to such nominees as Micron Technology, Inc. may designate.

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Docket No.: M4065.0477/P477

Micron No.: 01-0374

I agree that, when requested, I shall, without charge to Micron Technology,
Inc. but at its expense, sign all papers, and do all acts which may be necessary, desirable or
convenient in connection with said applications, patents, or other forms of protection.
O POS

NOTAR	Kevin M. Devereaux
Date: 8/24/01	
United States of America) State of	
On this 24 day of August personally came Kevin M. Deveredux described in and who executed the foregoing in	, <u>2001</u> , before me to me known to be the individual nstrument, and acknowledged execution
of the same.	Jay D. Robert Notary Public

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RECORDED: 08/28/2001